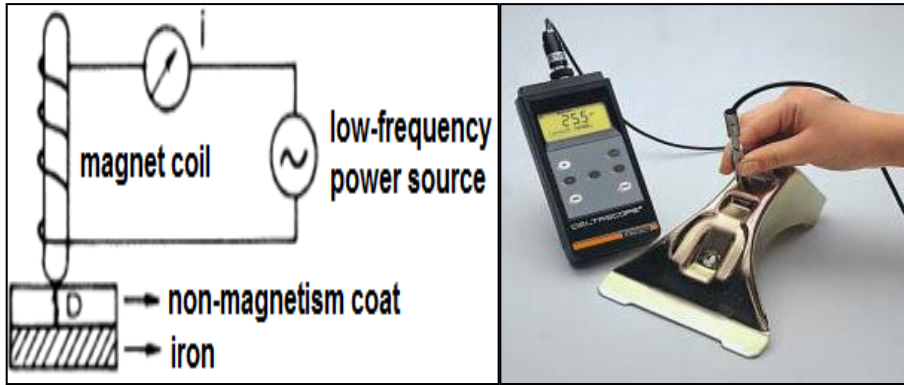


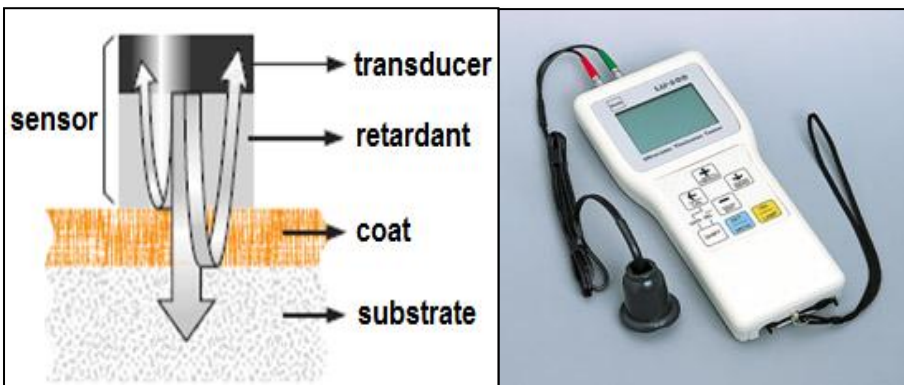
Measurable < 10 μm thick, Simultaneous, Non-destructive

Conventional Method

1. Electromagnetic film thickness meter

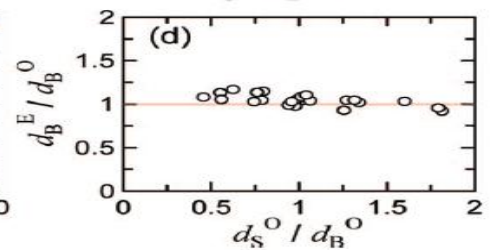
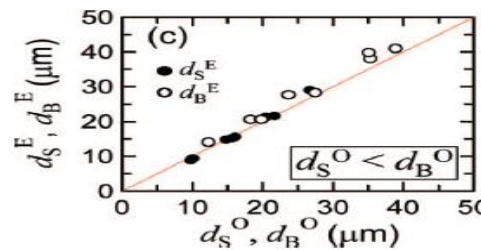
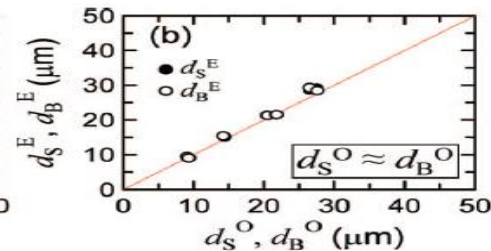
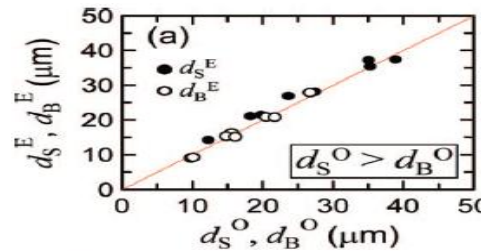
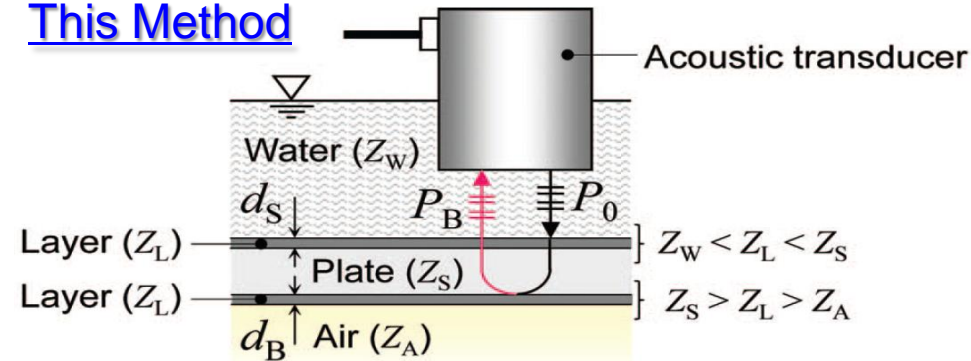


2. Ultrasonic film thickness meter



⇒ Unmeasurable less than 100 μm

This Method



【index】 s:surface, b:back, o:direct observation, E:evaluation

⇒ measurable less than 100 μm with a high degree of accuracy